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UNITED STATES PATENT AND TRADEMARK OFFICE

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Technology Center 1700

Mailed: 4/19/05

MEB  
Paper Number:

In re application of  
Kevin J. Lee  
Serial No. 09/223,472  
Filed: December 30, 1998  
For: Electroplating Cell Based Upon Rotational Plating  
Solution Flow

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DECISION ON  
PETITION

This is a response to the request to rescind the Notice of Abandonment, mailed November 16, 2004. This request is treated as a PETITION TO WITHDRAW ABANDONMENT, under 37 C.F.R. 1.181 (no fee required). The petition requests that the abandonment, as set forth in the Notice of Abandonment of November 16, 2004, for failure to timely reply to the Board of Appeals decision of September 2, 2004, be withdrawn. The petitioner asserts that the response was timely filed on November 2, 2004.

**DECISION**

USPTO records show that an appropriate response to the Board of Appeals decision of September 2, 2004 was filed with the office on November 5, 2004, with a Certificate of Mailing date of November 2, 2004, thus making the response timely. The application will be forwarded to the examiner for processing and consideration of the papers filed November 5, 2004.

The Petition is **Granted**.



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